



6P 2812

A28838-I-A
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hidemi Takasu
Serial No. : 09/212,915 Examiner: Unassigned
Filed : December 16, 1998 Group Art Unit: 2812
For : PROCESS FOR FABRICATING A
SEMICONDUCTOR DRIVE

5/I.D.S.
4-1-99

G. Stanley

INFORMATION DISCLOSURE STATEMENT

I hereby certify that this paper is being deposited with the United States
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March 15, 1999

Date of Deposit

Francis J. Hone

Attorney Name

[Signature]

Signature

18,662

PTO Registration No.

March 15, 1999

Date of Signature

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Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant requests that the references listed on the attached PTO-1440 and
discussed in the specification of the parent application SN 09/026,097, filed February 19,
1998, for the above-identified application be made of record in the Patent and Trademark
Office file relating to the application.

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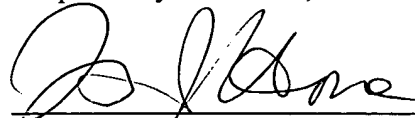
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Copies of these references are enclosed herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this paper to Deposit Account 02-4377. A duplicate copy of this sheet is enclosed.

Date: March 15, 1999

Respectfully submitted,

A handwritten signature in cursive script, appearing to read "F. J. Hone", written over a horizontal line.

Francis J. Hone
Patent Office Reg. No. 18,662

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Enclosures

